

Attorney Docket No. P128-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Jonathan Doan

Art Unit: Not Yet Assigned

Serial No.: Not Yet Assigned

Examiner: Not Yet Assigned

Filed: Herewith

For: **PRE-OXIDIZATION OF DEFORMABLE ELEMENTS OF MICROSTRUCTURES**

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Commissioner for Patents  
Alexandria, VA 22313-145

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached PTO Form 1449. Copies of the cited references are enclosed.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,



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<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>  SHEET 1 OF 2	ATTY. DOCKET NO.		SERIAL NO.	
	P128-US		Not Yet Assigned	
	APPLICANT Jonathan Doan			
	FILING DATE Herewith	GROUP Not Yet Assigned		

#### U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	Published Patent App No.US2002/0132 389 A1	09/19/02	Patel, et al.			
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#### FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
						<input type="checkbox"/>	<input type="checkbox"/>

#### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	S. Mubassar Ali, et al., USE OF THERMAL CYCLING TO REDUCE ADHESION OF OTS COATED MEMS CANTILEVERS, 2003, pp. 151-162.
	Michael R. Houston, et al., SELF-ASSEMBLED MONOLAYER FILMS AS DURABLE ANTI-STICKTION COATINGS FOR POLYSILICON MICROSTRUCTURES, 1996, pp.42-47.
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EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION  PTO-1449		ATTY. DOCKET NO. P128-US		SERIAL NO. Not Yet Assigned			
		APPLICANT Jonathan Doan					
		SHEET 2 OF 2		FILING DATE Herewith	GROUP Not Yet Assigned		
<b>U.S. PATENT DOCUMENTS</b>							
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
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	Uthara Srinivasan, et al., LUBRICATION OF POLYSILICON MICROMECHANISMS WITH SELF-ASSEMBLED MONOLAYERS, 1998, pp.156-161.						
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